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CONFIRMATION NO. 8859

| SERIAL NUMBER | FILING or 371(c) DATE | CLASS | GROUP ART UNIT | ATTORNEY DOCKET NO. | | |
|---|---|--|----------------------------------|---|--|---|
| 10/585,994 | 07/13/2006 | 438 438 | 2823 | 33082M336 | | |
| APPLICANTS Yasuo Kobayashi, Yamanashi-Ken, JAPAN; Kenichi Nishizawa, Kumamoto-ken, JAPAN; /K.P./ Takatoshi Kameshima, Yamanashi-ken, JAPAN; Takaaki Matsuoka, Tokyo-To, JAPAN; | | | | | | |
| ** CONTINUING DATA ***** This application is a 371 of PCT/JP2005/000297 01/13/2005 /K.P./ | | | | | | |
| ** FOREIGN APPLICATIONS ***** JAPAN 2004-005738 01/13/2004 /K.P./ JAPAN 2004-290846 10/01/2004 | | | | | | |
| ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 07/02/2008 | | | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/KEVIN A PAREDO/</u> Examiner's Signature | | <input type="checkbox"/> Met after Allowance Initials _____ | STATE OR COUNTRY JAPAN | SHEETS DRAWINGS 9 | TOTAL CLAIMS 12 8 | INDEPENDENT CLAIMS 4 1 |
| ADDRESS SMITH, GAMBRELL & RUSSELL 1130 CONNECTICUT AVENUE, N.W., SUITE 1130 WASHINGTON, DC 20036 UNITED STATES | | | | | | |
| TITLE Manufacturing Method Of Semiconductor Device And Film Deposition System | | | | | | |
| FILING FEE RECEIVED 1100 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | | |